

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hiroshi, et al.
Appl. No.: 10/563,630
Conf. No.: 1962
Filed: March 6, 2006
Title: NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR
PREPARATION THEREOF
Art Unit: 2818
Examiner: David J. Goodwin
Docket No.: 118075-002

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NON-FINAL OFFICE ACTION

Sir:

In response to the Office Action dated September 28, 2006, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.